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Surface Cleaning by Glow Discharge in a High-Volume Gas Flow

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Plasma Applications Branch Plasma Physics Division

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chamber volumes per minute. Such a large chamber is used instead of standard commercial glow-discharge devices to allow for many mean free paths for the contaminents to expand into and thus increase the time required to contact the chamber walls. This allows the sweeping action of the gas flow to move the contaminants downstream and thus reduce the probability of recontaminating either the chamber walls or the test surfaces. The cleaning effectiveness is compared by measuring the contact angles that high-surface-energy liquid drops make with the cleaned surface. The liquids used are triply distilled water for detecting hydrophobic contamination and methylene iodide for detecting water contamination. The surfaces used to demonstrate the cleaning technique were stainless steel and aluminum oxide. Some of the contact angles were too flat to observe but were estimated to be less than 1. The small contact angles are intrepreted to mean that there is less than 1 monomolecular layer of contaminant on the cleaned surface. and the same of the we will the const

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# SURFACE CLEANING BY GLOW DISCHARGE IN A HIGH-VOLUME GAS FLOW

#### INTRODUCTION

The problem of obtaining a surface which is uncontaminated by foreign substances (materials different from that of the pure surface) which may be adsorbed on the surface, such as water and the hydrocarbons common to the atmosphere, has been approached in many ways. Chemical cleaning, at the least, leaves a film of the final-rinse material. Sputtering a layer off the surface, leaving a clean layer, changes the structure of the surface. Sputtering on a new layer covering over the old surface with all its contamination (sweeping it under the rug) also changes the structure with no assurance that the new layer will not peel off. A "bakeout" may "bake on" the unknown substances initially contaminating the surface, depending on the contaminating substances and the nature of the material of the surface itself.

The problem has been discussed by many writing about vacuum systems, cleaning techniques, and their uses. Some of these authors are referenced [1-12] and have been valuable sources of information. Bombardment of the surface is common to the cleaning of surfaces, by both kinds of sputtering, off or on, and by "glow discharge," however the sputtering-off technique uses high-energy bombardment, whereas a glow-discharge method uses comparitively low energy particles (between 1 and 10 electron volts).

Previous use of ion bombardment has resulted in a limited cleaning action, because the atmosphere seems to become saturated with the contaminants from both the object to be cleaned and from the vacuum system it is being cleaned in. The result has been that the sample to be cleaned has been known to reach a condition of maximum cleanliness, after which further ion bombardment releases subsurface contaminants and the object becomes more contaminated.

The purpose of this report is to describe the hardware and the operation of a modified low-energy glow-discharge cleaning system and to report the results of the tests and subsequent conclusions about the effectiveness of the cleaning process. The purpose of this glow-discharge cleaning system is to demonstrate a system which will not recontaminate the cleaned sample and will eliminate the uncertainty of estimating the proper cleaning time for removing the test sample at its minimum contamination level.

#### PROCEDURES AND RESULTS

If a glow-discharge cleaning system will saturate with contaminants and recontaminate the object to be cleaned, then the best approach is to remove the contamination from the system as it is released from the surface of both the chamber and the object. Therefore the first modification to the cleaning system was allowing the glow-discharge gas to flow and the second show a second show the show what we are second

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through the chamber past the object and out through a cold trap. The rate of flow was the equivalent of at least 3 chamber volumes of gas per minute.

The second modification was to choose a chamber large enough so that there would be enough mean free paths between the walls of the chamber and the position of the sample to be cleaned to reduce the probabilities of recontamination of the chamber or of the sample by the newly released contaminants. (The details of the vacuum system are described in Appendix A, and the cleaning system is described in Appendix B.)

The third modification was in the procedure of backfilling the chamber with clean dry extra-pure nitrogen gas, which was also passed through a cooling coil immersed in a slurry of dry ice and acetone and then was reheated in a second coil before passing into the cleaning chamber. The idea was to trap what moisture and other impurities may have been left in the gas.

The fourth modification involved the procedure for measuring the contact angles (illustrated and explained in Fig. 1). A goniometer was combined with a 90-mm-focallength lens on a small optical bench (Appendix C, Fig. C1b) so that the drops inside a



Fig. 1 — Profile and contact angle of a liquid drop on a solid surface and (including the dashed section of the circle) the profile of the drop's related imaginary sphere. The contact angle  $\alpha$  of a liquid drop on a smooth, level solid surface is determined by the chemical and physical characteristics of the material (mutual solubility and surface tension) at the interface. In general the contact angle of a given drop is larger on a low-energy surface and smaller on a high-energy surface. For clean metal surfaces, and other high-energy solids which are "wet" by most liquids, a drop approaches a zero contact angle, and the measurement of the contact angle can be a sensitive means for detecting a monolayer or less of low-surface-energy contamination on the solid, such as water and various organic materials.

porthole protusion on the chamber could be visually observed through the porthole cover and their contact angles measured. The significance of this arrangement is that the sample did not have to be exposed to the laboratory atmosphere before the contact angle was measured. This takes on added significance in the following discussion of some of the experiments. All contact angle measurements, made after glow discharge cleaning, were made in the porthole with the pure nitrogen atmosphere, unless otherwise specifically mentioned. All samples were prepared as described in Appendix C.

All the results are documented in the tables in Appendix D. Figures 2a through 2e summarize the results of the tests for specific operating conditions as stated in the figure titles. The lower limit of the contact angle, which is too small to measure, indicates a surface free of both water and of substances which are hydrophobic. The theory of the significance of the small contact angle is discussed in a number of papers by Zisman and associates [9-11] and others. For  $I_2(CH_2)$ , when  $\alpha < 5^\circ$ , there is less than a monomolecular layer of water on the surface, with the amount reducing as the angle reduces. A similar criterion holds for the contact angles of  $H_2O$ : a low  $\alpha < 5^\circ$  indicates less than a monomolecular layer of hyrophobic substances such as paraffin, lubricating oils, pump oils, hydrocarbons, and halide carbons.







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Fig. 2b – Contact angles of H₂O drops on ungrounded stainless-steel samples cleaned at 0.005 torr and a radial distance R of 38 cm. The values plotted are listed in Table D2.







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Fig. 2d – Contact angles of  $I_2(CH_2)$  drops on ungrounded A1₂O₃ samples cleaned at 0.020 torr and a distance R of 18 cm using a total current of 0.200 A. The values are listed in Table D7 and (where indicated) Table D6a.



Fig. 2e — Composite plot of all data within the pressure range 0.002 to 0.200 torr and its related voltage range, the total-current range 0.100 to 0.400 A, and the distance-R range 18 to 38.7 cm. This plot indicates a trend toward increased cleanliness (decontamination) with time even though the conditions vary widely in the shorter time zones.

The starred point in the upper right of Fig. 2 may seem out of place. This is the result of a single experiment as follows: four samples were cleaned at one time by exposing them to the plasma for 60 minutes before the chamber was backfilled. Three samples were tested for cleanliness and showed contact angles of less than 10°. All four where left in the tank, which was pumped down again, and they were again plasma cleaned 10. 50 minutes; then the plasma was turned off, and the pumps were left running and the cleaning gas flowing for about 18 nours (overnight). The only difference from the cleaning mode was that the plasma was turned off. After the chamber was backfilled the following morning, the fourth sample was tested by contact-angle measurements and found to be more contaminated than it was before it had been put into the cleaning chamber (Table D4, run 13). The inference from this experiment is that the contamination was due to the continuous outgassing of the chamber in the low-pressure environment. In contrast to this another experiment was run in which, after the sample was cleaned for 60 minutes and then the chamber was backfilled, the cleaned sample was allowed to stay in the chamber overnight at a pressure slightly above 1 atmosphere. In this case the contact angles measured (Table D3, run 4) the same low angles measured on other samples immediately after the backfilling.

The implication from this test is that at 1 atmosphere pressure the outgassing of impurities from the chamber during about 18 hours is too low for the recontamination to be significant. This low recontamination rate also suggests the possibility of working with superclean materials and conducting assembly operations without fear of significant recontamination of the parts from the other materials in an environment, such as in a glove box.

A third experiment is illustrated in Fig. 3. Four samples were cleaned overnight, one was tested in the chamber before removing it from the porthole, and then all four samples were removed (Table D2, run 9). The second sample was tested by  $I_2(CH_2)$  drop and a water drop after a 10-minute exposure to air (at 65° F and with a measured relative humidity of 40%). The contact angle  $\alpha$  of the  $I_2(CH_2)$  droplet was back to where it was before the cleaning process and remained essentially the same for the following 3-hour and 6-hour time intervals. This indicates that immediately on exposure to the air of the room the surface was recontaminated with water film of the original order of magnitude, almost as if it had never been cleaned. The water drop however indicated a much lower rate of accumulation of hydrophobic substances on the clean surface, or on the water film already covering the surface. The different contamination rates are directly related to the relative amounts of the different amounts of contaminants available and on the existance of an ultimate state of equilibrium between the contamination density in the air and on the surface.

Figure 4 illustrates a series of experiments showing the contact angle as a function of the pressure, with the other controllable variables kept constant. These data show a trend toward more efficient cleaning at lower pressures. Since the current and time interval is the same for all pressures, then the total number of ion impacts must be unchanged; therefore the measured cleaning efficiency lies in the average increase in the amount energy imparted to the ions over the greater length of the mean free paths in the lower pressure regimes. This reasoning leads to further speculation that the combination of field-strength and mean-free-path control can lead to calculating the minimum conditions required for cleaning any surface when the bonding energies between the contaminants and the surface is known.

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The data from cleaning stainless-steel samples, whether obtained when electrically grounding them or when isolating them, showed no significant difference in cleaning quality, perhaps because the contact angles were all so small that any significance was buried in the gross differences between samples.

The effect of varying the position of the samples relative to the center electrode was similarly inconclusive. It was hoped that since the cylindrical field is stronger at its center than at the cylinder wall, greater current density and the higher ion energy near the center electrode would result in better cleaning and subsequently lower contact angles. However, although there may be a trend to substantiate these hopes, the data are not precise enough to support a position-effect hypothesis.

Similarly the effect of varying the current while keeping all other parameters unchanged did not result in significant or systematic reduction of the contact angle. Again this may be because the angles were already so small that the differences were hidden by the gross uncertainties such as the differences between samples evident from the data obtained prior to the plasma cleaning measurements. Even after preparing all the stainless-steel samples the same way in the same wash water and the same rinse water, there were differences in contact angles not only between samples but from one area to another of the same sample—not great differences, but measurable ones.

#### CONCLUSIONS

The main conclusion reached in this report is that a continuous flow of inert gas through a glow-discharge cleaning chamber results in test surfaces on which the contamination is significantly lower than on test surfaces cleaned in a chamber without the continuous gas flow. The contaminants appear to be simply swept out of the cleaning chamber before they can recontaminate the surfaces of the chamber or the samples.

A more sophisticated statement is that the continuous flow of clean inert gas reduces the saturation level of contaminants in the chamber until the probability of recombination of the contaminant with the surface approaches zero. A simple analogy is the superiority of a vacuum sweeper over a broom.

A trend is observed toward higher cleaning efficiencies at lower pressures, which supports the idea that the resulting increase in the mean free path of the ion allows it to accumulate more kinetic energy before impact. This trend is somewhat tempered by the related observation that the greater mean free path may also increase the probability of recontamination of the cleaned sample and the chamber walls; before the contaminants are removed from the cleaning chamber by the mass flow action of the gas. The mass flow of the gas can be effective in sweeping out the contaminants only if the mean free paths are short compared with the dimensions of the chamber. Hence the higher energy of the ions, which increase the probability of outgassing and decontaminating the surfaces exposed to them must be balanced by a sufficient number of mean free paths in the chamber to allow the gas flow to effectively remove them from the cleaning chamber. Also the bombardment frequency (current density) must be low enough so as to not heat the sample so much as to change its surface characteristics. Nor can the jons be so

energetic as to sputter off the surface material along with the contamination, since such a result is not compatable with the purpose of this experiment and has thus been deliberately avoided.

Thus the philosophy justifies a low-energy glow-discharge experiment as reported here.

#### ACKNOWLEDGMENTS

Thanks are due to Mr. J. Brown, Associate Superintendent, Plasma Physics Division, for his interest in, sense of responsibility for, and support of this project, to Elaine Shafrin of the Chemistry Division for the generous contribution of time spent in clarifying the relationship of contact angles to contamination levels on high-energy surfaces and for showing the techniques required for making reliable contact-angle measurements, to friends and associates who helped as well as advised on photographic problems, vacuum techniques, and general scientific and engineering support, and to Paul Carrol and the Machine Shop for fabricating critically important hardware (such as the sample holder) from imprecise drawings.

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#### Appendix A THE VACUUM SYSTEM AND INSTRUMENTATION

The vacuum system consists of a Stokes microvac Model 212-H forepump (Fig. A1) with a manufacturers rated pumping speed of 4000 liters/min (140 cu ft/min). It is connected to a jet pump (an Edwards vapor booster pump Model 94G) with a manufacturers rated pumping speed of 2800 liters/s. The two pumps are connected through a 10-cm gate valve, a 2.5-m-long 5-cm-diameter flexible pipe, and the jet-pump exit baffle, with a net conductance of about 340 liters/min at the jet pump exit to the baffle (assuming the Stokes forepump will pump 4000 liters/min at the pump entrance). Due to the architectural limitations of the assigned laboratory space, the connecting pipe to the elbow cold trap is an S-shaped pipe, 25 cm in diameter with an effective length of a complete 38-cm-centerline-radius toroid, plus a 125-cm straight pipe and a 25-cm-diameter gate valve, an equivalent of about 3 m. The cold trap is a 110-cm-high by 110-cm-long elbow, with an 80-cm inside diameter, and is equipped with both a chevron-type Freon-colled baffle and a pair of spherical liquid-nitrogen baffles. The cold trap is connected directly to the main vacuum chamber or cleaning chamber, which is a 3/2-cm-long cylinder, with an 80-cm inside diameter and closed by a removable plate at the other end.

A center electrode is suspended in the center of the cylinder which is insulated at both ends and is just short enough so that the respective ends are further away from the end plate and the cold trap than from the cylinder wall. The end plate has ports on it for the working gas and for the clean gas used to backfill the chamber. Mounted on the back plate are a leak valve for the working gas and a cooling coil for freezing out any possible moisture in the backfill gas ( $N_2$ ) plus a heating coil to heat the backfill gas again before it is expanded into the chamber.

Along the side of the chamber is a 30-cm-diameter porthole about 18 cm deep which serves as the experiment working space. The chamber has an 8-cm-diameter observation port on the top of the porthole and a small 2.5-cm-diameter access hole  $(45^{\circ} \text{ around to-ward the right side-facing the porthole})$ . Three other access cans are along the side of the chamber for attaching instrumentation and the electrical input to the center electrode.

The instrumentation is the flowmeter to the controlled leak valve, an Alphatron vacuum gauge, and a homemade manometer to assure that a positive pressure is reached before the small access hole is opened (to reduce probabilities of atmospheric contamination). A voltmeter and an ammeter is used to measure the total current through the sample. The dc power supply is a Regatron Model 222A with an output limited from 0 to 500 ma and 0 to 1000 V.

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Fig. A1 – Vacuum system and instrumentation

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# Appendix B THE CLEANING SYSTEM AND ITS CHARACTERISTIC VALUES

The forepump is a Stokes Model 212-H microvac pump. It is rated by the manufacturer to have a 4000 liter/min capacity at 1 atmosphere, which reduces to about 1700 liters/min at 0.100 torr. It is further reduced by the conductance through the connecting pipes to about 310 liters/min (by calculation) at the output of the Edwards Speedivac Model 94B. The Model 94B is rated at 2800 liters/s by the manufacturer and reduces to about 2750 liters/s by conductance to the cold trap.

Regardless of the manufacturers' claims, the system pumping performance is illustrated in Fig. B1 as it responded to a number of tests. Thus for example, to maintain a pressure of 0.100 torr, the use of the Stokes pump alone pumps about 9 cm³ of standardatmosphere argon per minute through the controlled leak valve, which expands to about



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68 liters/min as a pumping rate through the entire system. However, when the jet pump is active in the pumping system, the gas flow rate is off the scale of the flowmeter to maintain the 0.100-torr pressure, but at 0.080 torr the controlled leak valve meters a flow of  $150 \text{ cm}^3/\text{min}$ , which expands to about 1400 liters/min. At lower pressures, down to 0.005 torr, the flow rate increases dramatically.

The volume of the chamber is about 1590 liters, and the rest of the system through the cold trap and connecting pipes to the 25-cm gate valve is about 650 liters more, for a total of 2240 liters. Final tests of the system's leak and outgassing rates with the gate valve closed showed that the pressure increase was about 0.001 torr per hour. This is the equivalent of 2240 microtorr-liters per hour, or 0.62 microtorr-liters/s, which is the equivalent of 0.817 mm³/s of gas at one standard atmosphere. This leak rate is insignificant compared with the controlled leak rate for the operating system.

The inert gas used for glow-discharge cleaning was ultrapure argon purchased from the local source, the Southern Oxygen Division of the Air Products Company. The gas passes through a Granville-Phillips variable leak valve (Series 203) and then a Matheson flowmeter Model LF-100 into the inlet on the back plate of the chamber. The manufacturer's calibration correction curve for argon flow instead of air flow was used for all flow rates.

The surface of t'.e cleaning cylinder, including the end plate but not the cold trap is about 82,850 cm², which yields an average current density of about  $12 \,\mu\text{A/cm}^2$  per ampere of total current. If the inside area of the cold trap is included, the total inside area is about 110,000 cm², or about 33% more. The glow discharge frequently appears to jump into the cold-trap cavity and then go out. When this happens, the current at the power supply jumps about 25 to 30%, just about enough to account for the increased area if the surface current density remains the same. No further investigation was made of the phenomena.

It was assumed for the purpose of this experiment that the volume density of the ionized particles in this glow discharge was so low that the static electric field of a cylindrical configuration would be essentially undisturbed. Figure B2 illustrates the field strength, normalized to the electrode voltage  $(V_0)$ , as a function of distance from the center electrode, and was used to estimate the energy gain by a singly charged particle (ion) in the course of moving undisturbed through 1 mean free path length. This also assumes that the ion starts at rest or with the average kinetic energy of a particle at room temperature (which is rather insignificant compared to 1 electron-volt).

Figure B3 illustrates the results of measurements of the current and voltage required to maintain a glow discharge as a function of pressure. The anode voltage  $V_0$  is the estimated center electrode voltage resulting from

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where  $V_p$  is the voltage output of the power supply,  $I_p$  is the current output of the power supply, and  $I_pR$  is the resulting voltage drop across a standard 970-ohm resistance in the circuit. The chamber walls are the cathode and are at ground potential. The anode is at the center, so that the ion acceleration is essentially outward and perpendicular to the mass movement of the gas flow.

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Fig. B2 — Assumed cylindrical field strength, normalized to the electrode voltage, as a function of the radius



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The dc power supply is a Regitron Model 222A. It delivers current over the range of 0 to 500 mA at voltages ranging from 0 to 1000 V. It is connected in series through a wire-wound resistor rated at 973 ohms to the center electrode. No attempt was made to calibrate resistance as a function of temperature, because the currents used were usually small enough so that the resistor did not get too hot to hold.

The backfilling gas, used to bring the chamber pressure back to slightly above 1 atmosphere was ultrapure nitrogen purchased from the same course as the argon: the Southern Oxygen Division of the Air Products Company. The nitrogen was passed through a coil immersed in a dry ice and acetone slurry so as to freeze out any contaminants which might be present and then was passed through a second coil, where it was heated to about room temperature before expanding into the chamber.

#### Appendix C GLOW-DISCHARGE CLEANING OPERATION

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# CHEMICAL CLEANING AND PREPARATION OF SAMPLES FOR THE GLOW-DISCHARGE EXPOSURE

Except for some preliminary data (Table D1) all 16 stainless-steel samples were given a mirror polish such that all scratches were removed. After they were polished, they were soaked overnight in a 10% sodium hydroxide mixture and then rinsed and washed in a solution of Sparkleen and distilled water. The 16 pieces were rinsed as a group in three changes of distilled water and once in 2-propanol. Then they were air dried. The purpose in preparing the samples in this way was to let all the samples share all sources of possible contamination at the same time. For all subsequent prepartions the sodium hydroxide was not used.

The aluminum oxide samples included two alumina gyro bearings from Avco, two artificial sapphire chips, and two ruby chips. These were cleaned with only the Sparkleen wash and distilled water rinses, since the alumina might chemically react with the sodium hydroxide and be destroyed.

#### CONTACT-ANGLE MEASUREMENTS

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All samples were tested by measuring the contact angle of a drop of methylene oxide on one corner, and a drop of triply distilled water on another corner before being placed in the cleaning chamber for glow-discharge exposure.

After glow-discharge cleaning, all contact angles were measured through the observation window before the sample was exposed to the laboratory atmosphere. This measurement technique requires a modification of the goniometer optics so as to make it possible to see the objects inside of the porthole and is best described by the two examples in Fig. C1.

Figure C1a is the standard setup, with the drop about 6 to 7 cm from the object lens of the gonimeter. This setup is used to measure the precleaning contact angles. Figure C1b is the modified setup required to see through the window to the sample. There are not insurmountable difficulties with this, but the image of the drop is degraded. The angle measurements are reproducable to  $\pm 1^{\circ}$  down to about 6° or 7°. They become uncertain below 5°, depending on the quality of the image, which is sometimes good but more often poor, depending on the placement of the optical system and the limited time required to make the optimum adjustment.

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(a) Sample and drop outside the chamber



Fig. C1 - Optical arrangements for measuring contact angles

#### PUMPDOWN, GAS FLOW, AND GLOW DISCHARGE

After the vacuum system has been closed and checked against a checkoff list, the forepump is turned on and allowed to pump down to about 1 torr before the cold-trap refrigeration unit and jet-pump heater are turned on. This keeps most of the humidity from clogging up the chevron baffles, which could reduce the conductivity of the vacuum system. After the pressure has stabilized at about 0.0005 to 0.0010 torr, the controlled leak is opened and the pressure builds up to the desired pressure and is allowed to stabilize before the power is turned on for the glow discharge. When the glow discharge is first turned on, the gas flow needs continual adjustments for about 10 minutes to maintain a constant pressure, after which it settles down to a rather constant flow.

For subsequent starts the cold-trap refrigeration is on all the time, because the backfilling gas is dry, and because it keeps recontamination of the system from the cold trap to a minimum. Also the 25-cm gate valve is closed for the backfilling operation so the heater to the jetpump is turned off and allowed to cool until it is about time to restart. At that time the forepump is turned off and air is bled into the pumping side of the 25cm gate valve to equalize the pressure before opening it for the next start. For subsequent starts the forepump and the jet-pump heater are turned on at the same time.

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The gas flow is always turned on after the pumping system has stabilized at its lowest pressure (somewhere between 0.0005 and 0.0010 torr, depending on its mood) so as to build the pressure up to the desired level in a minimum time. Letting the pumping system first reach stabilization also assures that most of the gas in the chamber is argon, since the pumping system has literally swept out the remaining gaseous residues such as nitrogen, oxygen, and water vapor.

Argon is used because it is the cheapest chamically inert gas available (ionized nitrogen is chemically active) and because as an ionized ballistic missile it has enough mass to dislodge hydrocarbon and water-molecule forms of surface contamination. Particle contamination, such as dust, will probably not be disturbed, so the only consideration given to particles is to those which are not removed by the preparation process; they remain to be cleaned by the glow-discharge process.

The glow discharge was operated between 0.002 torr and 0.2 torr, and at currents between 0.100 and 0.400 A, with whatever voltage was required. It was turned on after the pressure and gas flow was stabilized and turned off at the end of a predetermined time interval. It was mentioned in Appendix B that the average current to the walls of the chamber were  $12 \,\mu A/cm^2$  per ampere; however this does not hold true for the samples which were not attached to the wall but were suspended into the chamber. For example, Figure. C2 shows the verification of the average current through a 6.5-cm² sample at 18 cm from the anode and how it changes with total current and with pressure. These samples were connected to ground through a sensitive ammeter. The experimental data, obtained between January 10 and January 15, 1975, is given in Appendix D (Tables D3).



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After the cleaning time is over, the chamber is immediately backfilled with clean dry nitrogen gas to a pressure slightly above 1 atmosphere. When the small access hole or the side of the porthole is opened to put a test drop on one of the samples, the greater pressure on the inside reduces the probabilities of contamination from the laboratory atmosphere before the contact angles are measured. It turned out, as one of the experiments show, that after a sample sat in the backfilled chamber for 16 hours (overnight), the measured contact angles were comparable with those obtained immediately after backfilling was completed. Thus slight delays probably do not influence the results.

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# Appendix D DATA AND COMMENTS

The data in Tables D1 through D7 are listed as originally recorded. This is a record of the effort to identify the comparative absence of contamination on certain select surfaces of stainless steel, except for  $A1_2O_3$  at the last in the forms of sapphire, ruby, and ceramic. During the experiments it was decided that some items were of little value and some procedures were not productive, and then again that something missing from the early observations needed to be included. It was discovered early that putting a drop of methylene iodide on one side of a sample and a drop of water on the other side of the same sample did not seem to change the size of the contact angle of either drop regardless of which one was put on first, except in the case of spontaneous spreading, in which case no attempt was made to put two drops on one sample. However putting two drops on one sample otherwise made twice as many observations possible. The ritual was to put the methylene iodide on first, since it had a higher density and a lower vapor pressure.

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The first few runs were exploratory; they tested out the upper and lower limits of the pressure and energy and tried out the results with an  $\alpha$ -bromonapthalene drop. It was decided during these experiments to use only methylene iodide to detect water films, since  $I_2(CH_2)$  is highly hydrophobic and has a high surface tension, and to use water to detect hydrophobic films. Contamination present on the surface, after otherwise careful cleaning of particulate matter, should be mostly attributable to contaminants present in the air and the cleaning solutions themselves, such as soap film, water, human breath residues, and body odor. Perhaps their presence could not be identified, but their absence could be.

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Table D1 — Series—I Glow-Discharge-Cleaning Data: Contact Angles of Drops on Ungrounded Stainless-Steel Samples on a Stainless-Steel Holder

		Grounde			oumpico	<u> </u>						
	E	(Trada)	A			Con	tact An	gle, α	(deg)			
Sample Number	Time	Current	$Current^*$	Gas	Pressure (torr)	Н	2 ⁰	I ₂ (	CH2)	Remarks		
	(1111)		(µA/en )			Left	Right	Left	Right			
Run 1 — distance discharge water.	Run 1 — Unpolished samples outside the chamber in air and then inside the chamber in argon at a radial distance R from the center electrode = 38.7 cm (wall distance). This run was over a weekend to glow-discharge clean the system. The samples were washed only with soap and water and rinsed with distilled water.											
1	0	0	0	Air	760	-	-	35	34	_		
2	0	0	0	Air	760	84	85	] _	-	_		
1	60	0.109	1.2	Argon	0.200	-	-	17	18	_		
2	3840	0.100	1.2	Argon	0.200	-	-	?	?	$I_2(CH_2)$ too thin to measure		
3	3840	0.100	1.2	Argon	0.200	-	_	4	6	-		
4	3840	0.100	1.2	Argon	0.200	-	-	?	?	I2(CH2) too thin to measure		
Run 2 — Appendi	Run 2 — Unpolished samples, at $R = 38.7$ cm when in the chamber. The chemical cleaning procedure of Appendix C was used.											
1	0	0	0	Air	760	-	_	35	42	. –		
4	0	0	0	Air	760	85	80	-	-	-		
1	30	0.200	2.4	Argon	0.020	?	<4	-	-	Reflections ob-		
2	30	0.200	2.4	Argon	0.020	-	-	?	9	scured the left		
3	30	0.200	2.4	Argon	0.020	-	-	?	14	side of the drop		
4	30	0.200	2.4	Argon	0.020	?	<4		-	J profile		
Run 3 –	Newly pol	ished sam	ples with no	o preclea	ning, at F	t = 38.	7 cm w	hen ir	the ch	amber.		
1	0	0	0	Air	760	110	105	-	-	_		
2	0	0	0	Air	760	108	108	-	-			
3	0	0	0	Air	760	-	-	38	39	$\alpha$ — Bromonapha- lene instead of		
4	0	0	0	Air	760			35	40	$I_2(CH_2).$		
1	180	0.100	1.2	Argon	0.005	-	-	?	?	<u></u> \α−Bromonapha		
2	180	0.100	1.2	Argon	0.005	-	-	?	?	$\int$ lene, too thin to measure		
3	180	0.100	12	Argon	0.005	40	2		-	Reflections ob-		
4	180	0.100	1.2	Argon	0.005	35	?	-	-	scured the right		
1	1	1		1	1	ľ		1	1	and or me urop		

*Averaged over the inside area of the chamber.

Table continues

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Sample NumberExposure Time (min)Total Current (A)Average Current ( $\mu$ A/cm ² )GasPressure (torr)Contact Angle, $\alpha$ (deg)RefH2OI2(CH2)LeftRightLeftRightRef	narks										
Sample NumberExposure Time (min)Ital Current (A)Average Current ( $\mu$ A/cm ² )GasPressure (torr)H2OI2(CH2)RenRun 4 - Polished Samples, at R = 38.7 cm when in the chamberRun 4 - Polished Samples, at R = 38.7 cm when in the chamberRun 4 - Polished Samples, at R = 38.7 cm when in the chamberRun 4 - Polished Samples, at R = 38.7 cm when in the chamberRun 4 - Polished Samples, at R = 38.7 cm when in the chamber	narks										
Run 4 - Polished Samples, at R = 38.7 cm when in the chamber											
Run 4 — Polished Samples, at $R = 38.7$ cm when in the chamber											
Run 4 – Polished Samples, at $R = 38.7$ cm when in the chamber											
$ \begin{array}{c ccccccccccccccccccccccccccccccccccc$	  ht clean- ≈ 20 hr. eous										
Run 5 – Polished samples, at R = 28 cm. (Sample 1 was checked with an Auger Spectrometer with incor- clusive results; nothing was found except stainless steel.) The contact angle $\alpha \neq \alpha$ sestimated by the spreading ratio n using Eqs. (6) and (3c) of Appendix E.											
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$	-* p diame- ad from ≈ to ≈ 7 30 s. ore n > 4.										
Run 6 – A different set of polished samples, at R = 38.7 cm											
$ \begin{bmatrix} 5 & 30 & 0.100 & 1.2 & Argon & 0.005 & 18 & ? & - & - \\ 6 & 30 & 0.100 & 1.2 & Argon & 0.005 & 22 & ? & - & - \\ 7 & 30 & 0.100 & 1.2 & Argon & 0.005 & 14 & ? & - & - \\ 8 & 30 & 0.100 & 1.2 & Argon & 0.005 & 30 & ? & - & - \\ \end{bmatrix} Reflect$	ions ob- he right the drop										
Run 7 – Polished samples, at $R \approx 35$ cm											
$ \begin{bmatrix} 1 & 30 & 0.100 & 1.2 & Argon \\ 2 & 30 & 0.100 & 1.2 & Argon \\ 3 & 30 & 0.100 & 1.2 & Argon \\ 4 & 30 & 0.100 & 1.2 & Argon \\ \end{bmatrix} \begin{bmatrix} 0.005 & 12 & 12 & - & - & - \\ 0.005 & 8 & 10 & - & - & - \\ 0.005 & 10 & 15 & - & - & - & - \\ 0.005 & 10 & 14 & - & - & - & - \\ \end{bmatrix} \begin{bmatrix} n \approx 3^{\dagger} \\ n \approx 3^{\dagger} \\ n \approx 3^{\dagger} \end{bmatrix} $											

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# Table D1 (Continued) — Series—I Glow-Discharge-Cleaning Data: Contact Angles of Drops on Ungrounded Stainless-Steel Samples on a Stainless-Steel Holder

*This sample went to ar Auger Spectrometer. The results were inconclusive; nothing was found except the

expected components of stainless steel. The results were incoherentiative, nothing was round except in the spreading ratio  $n \approx 3$  observed in supplementary to the direct measurement  $\alpha = 12^{\circ}$ . In the case of run 8, samples 1 through 3, for example, a direct measurement of  $\alpha$  was not possible, and the value <10 listed is that determined by observing that n > 3.

**Table Continues** 

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	Exposure	Total	Average			Con	tact Ar	igle, α	(deg)	- -
Number	Time	Current	Current	Gas	(torr)	Н	2 ⁰	I ₂ (0	CH ₂ )	Remarks
	(1111)	(A)	(µA/CIII-)			Left	Right	Left	Right	
Run 8 — Polished samples, at R = 38 cm										
5 6 7 8	30 30 30 30	0.100 0.100 0.100 0.100	1.2 1.2 1.2 1.2	Argon Argon Argon Argon	0.005 0.005 0.005 0.005	1 1 1 1		???????????????????????????????????????	<10 <10 <10 <5	$\left.\begin{array}{c}n>3\Rightarrow\alpha<10\\ \text{Reflections}\\ \text{obscured the left}\\ \text{side.}\\ n>4\Rightarrow\alpha<5.\\ \text{Reflections obscured left side.}\end{array}\right.$
Run 9 —	Polished sa	mples, at	R = 38.7 cr	n						· · · · · · · · · · · · · · · · · · ·
1 2	30 30	0.070 0.070	0.85 0.85	Argon Argon	0.002 0.002		-	30 34	??	Reflections ob- scured the right side.
3 4	30 30	0.070 0.070	0.85 0.85	Argon Argon	0.002 0.002	? ?	35 22	-	_	Reflections ob- scured the left side

# Table D1 (Concluded) — Series—I Glow-Discharge-Cleaning Data: Contact Angles of Drops on Ungrounded Stainless-Steel Samples on a Stainless-Steel Holder

Sam- Expos. Current			Gas Flow		Con	tact An	gle, α	(deg)	ļ		
ple	Time	Total	Average	Gas	Rate	Pressure (torr)	H	2 ⁰	I ₂ (0	CH ₂ )	Remarks
140.	(11111)	(A)	(µA/cm ² )		(emo/mm)		Left	Right	Left	Right	
Run 🛛	10 (5 No	ov. 1974	4) — Polishe	ed samp	les, at R = 3	8 cm whe	n in t	he char	nber		
5 6 7 8	0 0 0 0	0 0 0 0	0 0 0 0	Air Air Air Air		760 760 760 760 760	<u> </u>	?.?.	·	?:?:	No data, because photographs of the drops were underexposed.
5 6	30 30	0.100	$\begin{array}{c} 1.2\\ 1.2\end{array}$	Argon Argon	34 34	0.006 0.006	-	=	<10 <10	<10 <10	tions obscured
7 8	30 30	0.100 0.100	$\begin{array}{c} 1.2\\ 1.2\end{array}$	Argon Argon	34 34	0.006 0.006	=		<5 <5	<5 <5	n > 4. Reflections obscured the profiles.
Run : water	l 1 — Pol	ished s	amples, at l	R = 28 c	m. The sam	nples were	not p	oreclear	ied wi	th NaO	H or soap and
9 10	30 30	0.100 0.100	1.2 1.2	Argon Argon	36 36	0.006 0.006	36 42	??	28 31	??	Reflections ob- scured the right side.
11 12	30 30	0.100 0.100	1.2 1.2	Argon Argon	36 36	0.006 0.006	??	40 45	?	21	Reflections ob- scured the left side.
Run	12 — Po	lished s	amples at R	l = 28 c	m						
13 14 15	30 30 30	0.100 0.100 0.100	1.2 1.2 1.2	Argon Argon Argon	36 36 36	0.006 0.006 0.006	18 12 -	28 ? —	- - <10	- - <10	Reflections ob- scured right side.
16	30	0.100	1.2	Argon	36	0.006	<u> </u>		<10	<10	u / 0.

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Sam	Funce	C	urrent		Geo Flow		Cont	act An	gle, α (	(deg)	
ple	Time	Total	Average	Gas	Rate	Pressure (torr)	H	2 ⁰	I ₂ (	CH ₂ )	Remarks
NO.	(mn)	(A)	$(\mu A/cm^2)$		(emo/mm)		Left	Right	Left	Right	
Run 1	l (22 No	ov. 1974	4) — Sample	es at R	= 35 cm wh	en in the c	hamb	er			
$\frac{1}{2}$	0	0	0	Air Air	0	760 760	70 65	70 70	=		-
1	60	0.100	1.2	Argon	36	0.005	10	?	-	-	Reflections ob-
2	60	0.100	1.2	Argon	36	0.005	10	12		-	-
3	60	0.100	1.2	Argon	36	0.005	16	?	-	_	Reflections ob-
4	60	0.100	1.2	Argon	36	0.005	<10	<10	-	-	$n \ge 3 \Rightarrow \alpha < 10.$
Run	2 (5 Dec	. 1974)	– Samples	at R =	38 cm wher	n in the ch	ambe	r			
5 6 7	0 0 0	0 0 0	0 0 0	Air Air Air	0	760 760 760	80 90 70	80 85 75	  50	- - 52	
5	90	0.100	1.2	Argon	34	0.005	16	?	17	40	-
67	90	0.100	1.2	Argon	34	0.005		14	16	13 7	-
8	<b>9</b> 0	0.100	1.2	Argon	34	0.005	<u>-</u>	-	17	?	-
Run	3 (9 Dec	. 1974)	– Samples	s at R =	38 cm						
9 10 11 12	60 60 60 60	0.100 0.100 0.100 0.100	1.2 1.2 1.2 1.2 1.2	Argon Argon Argon Argon	?????	0.002 0.002 0.002 0.002	12 15 13 15	17 18 23 21	11 6 12 25	12 7 10 ?	Reflections ob- scured at right of I ₂ (CH ₂ )
Run 4	4 (10 De	c. 1974	l) — Sample	es at R =	= 38 cm whe	en in cham	ber			·	
13	0	0	0	Air	0	760	27	30	=		-
15	ŏ	lŏ	ŏ	Air	ŏ	760	43	37	-	_	_
16	0	0	0	Air		760	40	38	-	-	—
13	60	0.100	1.2	Argon	25	0.015	23	21			-
15	6ŏ	0.100	1.2	Argon	25	0.015	1 -	=	15	15	
16	60	0.100	1.2	Argon	25	0.015	-	-	19	15	-

 Table D2 — Series—II Glow-Discharge-Cleaning Data:
 Grounded Polished

 Stainless-Steel Samples on a Lucite Holder

**Table Continues** 

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Same	am- Expos. Current		urrent		Cas Flow		Con	tact An	gle, α	(deg)	
ple	Time	Total	Average	Gas	Rate	Pressure (torr)	Н	₂ 0	I ₂ (	CH ₂ )	Remarks
190.	(min)	(A)	$(\mu A/cm^2)$		(cmo/min)		Left	Right	Left	Right	
Run {	5 (11 De	c. 1974	l) — Sample	s at R =	= 18 cm						
1	60	0.200	2.4	Argon	24	0.006	-	_	15	15	_
3	60 60	0.200	2.4	Argon	24 24 24	0.006	5	5	-	10	_
Hun f	3 (11 De	0.200	2.4	e at R :	= 38 cm who	n in the c	hamh	or			
ream e		0		Alu	00 cm with		00				
5	0	0	0	Air Air	0	760	20 20	23 22	_	_	-
8	0	0	0	Air Air	0	760 760	22 22	20 25	-	_	=
5 6	120 120	0.200	2.4 2.4	Argon Argon	24 24	0.006	<5	<5	11 15	10 20	Ξ
7 8	120 120	0.200 0.200	2.4 2.4	Argon Argon	24 24	0.006 0.006	<5 <5	<5 <5	 15	11	$n > 4 \Rightarrow \alpha < 5. n > 4 \Rightarrow \alpha < 5.$
Run ?	7 (12 De	ec. 1974	1) — Sample	es at 38	cm when in	the cham	ber	L		ا <u>ـــــــا</u>	
9	0	0	0	Air	0	760	85	88	_	-	-
11	0	0	0	Air Air	0	760		88	38	38	-
12 9	0 120	0.200	0 2.4	Air Argon	0 24	760 0.005	_	=	$\frac{38}{5}$	$ ^{38}_{<5} $	۔ Photographs not
10 11	1 20 1 20	0.200	2.4 2.4	Argon Argon	24 24	0.005		- 	<5	<5	good enough; too many
12	120	0.200	2.4	Argon	24	0.005	<3	<3			J reflections.
Run	Run 8 (12 Dec. 1974) — Samples at R = 28 cm when in the chamber										
1 2	0	0	0	Air Air	0	760 760	=	=	30 30	30 31	-
3	Ŏ	Ŏ	0 0	Air Air	, Ŏ	760	54 63	53 63	_	-	-
1 2	120 120	0.200	2.4	Argon	24 24	0.005	<2.5	<2.5 <2.5	_	_	$n > 5 \Rightarrow \alpha < 2.5.$
3 4	120 120	0.200	2.4 2.4 2.4	Argon Argon	24 24	0.005	₹5 ₹5	\$5 \$5	<b>≤</b> 5 <b>5</b>	<5 <5	$\begin{cases} n > 4 \Rightarrow \alpha < 5. \end{cases}$

 Table D2 (Continued) — Series—II Glow-Discharge-Cleaning Data:
 Grounded Polished

 Stainless-Steel Samples on a Lucite Holder

Table Continues

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S	Eunas	C	urrent		Cas Flow		Con	tact Ar	ngle, α	(deg)	
ple	Time	Total	Average	Gas	Rate	Pressure (torr)	Н	20	I ₂ (	CH ₂ )	Remarks
INO.	(min)	(A)	$(\mu A/cm^2)$		(eme/min)		Left	Right	Left	Right	
Run 9 (6 Jan, 1975) – Test of the time until conta nination after cleaned samples are expose tory air at 65 F and 40% relative humidity. The samples were cleaned at $R = 38$ cm.									exposed to labora-		
5	0	0	0	Air	0	760	32	30	-	-	_
6	0	0	0	Air	0	760	28	27	1	-	_
8	l v		l N	An		760	-	_	40	41	
5	1080	0.200	2.4	Argon	28	0.005	<2.5	<2.5	<ĩ	l <i< td=""><td>Still inside the</td></i<>	Still inside the
6	1080	0.200	2.4	Argon	28	0.005	<5	<5	32	37	chamber. $n > 5 \Rightarrow \alpha < 2.5;$ $n > 7 \Rightarrow \alpha < 1.$ After 10 min out of the chamber.
7	1080	0.200	2.4	Argon	28	0.005	30	28	36	34	$n > 4 \Rightarrow \alpha < 5.$ After 180 min out
8	1080	0.200	2.4	Argon	28	0.005	33	33	32	32	After 360 min out of the chamber.
Run	10 (7 Ja	n. 1975	) — Sample	s at R :	= 38 cm whe	n in the c	hamb	er	·	1	· · · · · · · · · · · · · · · · · · ·
9	0	0	0	Air	0	760	45	43	30	28	-
10	Ó	0	Ó	Air	0	760	40	40	32	28	-
9	60	0.100	1.2	Argon	30	0.005	10	10	18	18	-
	00	0.100		Argon	30   30	0.005	N N	8	20		
12	60	0.100	1.2	Argon	30	0.005	1 7	6	18	15	-

Table D2 (Concluded) — Series—II Glow-Discharge-Cleaning Data: Grounded Polished Stainless-Steel Samples on a Lucite Holder

Note: In Subsequent tables the gas flow rate will be expressed as millitorr-liters per minute. Since 1 atmosphere =  $7.6 \times 10^5$  millitorr and 1 cm³ =  $1 \times 10^{-3}$  liters, then  $7.60 \times 10^5$  millitorr  $\times 10^{-3}$  liters/min = 760 millitorr-liters/min. As an example, a flow of 30 cm³/min at 1 atmosphere is 22800 millitorr-liters/min, and at a pressure of 5 millitorr this translates into 22800/5 = 4560 liters/min. From Appendix B the volume of the chamber is 2240 liters, which is (conveniently) about 2280 liters, so that a flow of 4560 liters/min represents 2 chamber volumes per minute. This approach can be applied to the preceding data as well.

Table D3a – Series-IIIA Glow-Discharge-Cleaning Data: Grounded Freshly Polished Stainless-Steel Samples on a Lucite Holder, with the Sample (Having Residual Contamination) Exposed to the Glow Discharge for 60 min at R = 18 cm in Every Run and the Pressure Being Doubled Each Time in the Sequence of Runs at a Total Current of 0.100 A (Runs 1, 3, 5, 7, 9, 10) and in the Sequence of Runs at a Total Current of 0.300 A (Runs 2, 4, 6, 8). The Gas Flow Rate was not Recorded.

Fynas	C	urrent				Con	tact Ar	ngle, $\alpha$	(deg)		
Time	Total	Sample*	Gas	Pressure (torr	R (cm)	Н	20	I ₂ (0	CH ₂ )	Remarks	
("m)	(A)	$(\mu A/cm^2)$				Left	Right	Left	Right		
				Run 1 (10	) Jan. 1	1 <b>9</b> 75)	— Samp	ole 1			
$\begin{array}{c c c c c c c c c c c c c c c c c c c $											
Run 2 (10 Jan. 1975) — Sample 2											
0 60	0 0.300	0 30.2	Air Argon	760 0.005	 18	112 <5	105 <5	65 <1.5	63 <1.5	$n > 4 \Rightarrow \alpha < 5; n > 6 \Rightarrow \alpha < 1.5$	
Run 3 (13 Jan. 1975) — Sample 3											
0 0 60	0 0.100 0.100	0 7 11	Air Argon Argon	760 0.012 0.012		104 24	104 22	51 <2.5	<u>56</u> <2.5	n > 5 $\Rightarrow \alpha$ < 2.5 Perhaps the current increases with exposure time due to re- duced resistance on the surface as the sample gets cleaner.	
				Run 4 (1	3 Jan.	1975)	— Sam	ple 4			
0 0 60	0 0.300 0.300	0 18.6 22.5	Air Argon Argon	760 0.012 0.012	 18 18	108 30	108 32	$\frac{64}{<2.5}$	<u>66</u> <2.5	$\frac{-}{n > 5 \Rightarrow \alpha < 2.5}$	
	Run 5 (13 Jan. 1975) — Sample 5										
0 0 60	0 0.100 0.100	0 9.5 10.1	Air Argon Argon	760 0.025 0.025	- 18 18	108 8	107 8	63 <5	62 <5		

*Direct measurement on the sample with a microammeter.

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Table D3a (Concluded) — Series-IIIA Glow-Discharge-Cleaning Data: Grounded Freshly Polished Stainless-Steel Samples on a Lucite Holder, with the Sample (Having Residual Contamination) Exposed to the Glow Discharge for 60 min at R = 18 cm in Every Run and the Pressure Being Doubled Each Time in the Sequence of Runs at a Total Current of 0.100 A (Runs 1, 3, 5, 7, 9, 10) and in the Sequence of Runs at a Total Current of 0.300 A (Runs 2, 4, 6, 8). The Gas Flow Rate was not Recorded.

Euros	current					Con	tact An	lgle,α	(deg)		
Time	Total	Sample*	Gas	Pressure (torr)	R (cm)	Н	₂ 0	I ₂ (0	CH ₂ )	Remarks	
(min)	(A)	$(\mu A/cm^2)$				Left	Right	Left	Right		
	Run 6 (14 Jan. 1975) — Sample 6										
$\begin{bmatrix} 0 & 0 & 0 \\ 0 & 0.200 & 14.6 & Argon & 0.025 & 18 & -112 & 115 & 65 & 68 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & -120 & $										_	
60	0.300	14.6	Argon	0.025	18	-8	6	<2.5	<2.5	$n > 5 \Rightarrow \alpha < 2.5$	
				Run 7 (1	4 Jan.	1975)	— Sam	ple 7			
0	0	0	Air	760		100	100	60	64	-	
60	0.100	3.0 4.1	Argon	0.050	18	8	7	<5	<5	_	
				Run 8 (1	4 Jan.	1975)	- Samj	ple 8			
0	0	0	Air	760	18	97	<u>96</u>	68	87	_	
60	0.300	8.7	Argon	0.050	18	<5	<5	<5	<5	$n > 4 \Rightarrow \alpha < 5$	
				Run 9 (1	4 Jan.	1975)	— Sam	ple 9		· · · · · · · · · · · · · · · · · · ·	
0	0	0	Air	760	-	106	105	61	61	-	
60	0.100	8.5	Argon	0.100	18	10	12	13	10	-	
	Run 10 (15 Jan. 1975) — Sample 10										
0	0	0	Air	760	-	107	107	62	61	-	
60	0.100	9.0	Argon	0.200	18	9	10	10	11	n ≈ 3	

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Table D3b - Series-IIIB Glow-Discharge-Cleaning Data: Grounded Freshly Polished Stainless-Steel Samples on a Lucite Holder. The Exposure Time was Increased Each Run, with the Total Current Being 0.300 A and R = 18 cm for all Runs. The Date was 15 Jan. 1975.

P	С	urrent				Con	tact An	gle, α (	deg)	
Time	Total	Sample	Gas	Pressure (torr)	R (cm)	Н	2 ⁰	I ₂ (0	CH ₂ )	Remarks
(min)	(A)	(µA/cm ² )				Left	Right	Left	Right	
				Run 1 – 5	Sample	11				
0 0 10	0 0.300 0.300	0 25 30	Air Argon* Argon*	760 0.005 0.005	- 18 18	99  12	101 	59 - 41	61 	
				Run 2 —	Sample	12				
0 0 20	0 0.300 0.300	0 31 39.7	Air Argon* Argon*	760 0.005 0.005	 18 18	105 	108 	60 - 15	60 18	_
				Run 3 —	Sample	13				
0 0 30	0 0.300 0.300	0 25 31	Air Argon* Argon*	760 0.005 0.005	 18 18	108 ~10	107 ≈10	62 - - 2.5	$\underbrace{\frac{61}{<2.5}}$	$\frac{-}{n > 5 \Rightarrow \alpha < 2.5.}$
				Run 4 —	Sample	14				
0 0 60 960‡	0 0.300 0.300 0	0 25 30 0	Air Argon* Argon* Nitrogen†	760 0.005 0.005 780	 18 18 18	105  <10	106  <10	60 - - <2.5	61 - <2.5	$n \ge 3 \Rightarrow \alpha < 10;$ $n \ge 5 \Rightarrow \alpha < 2.5.$

The gas flow rate was not recorded. The gas flow rate was zero. ‡Run 4 in series IIIB can be considered in conjunction with run 13 in series IV. In run 13 in series IV the sample was cleaned and then exposed to a low-pressure argon flow without glow-discharge cleaning over-night (18 hours = 1080 minutes) and came out as contaminated as before the cleaning, whereas in run 4 above a comparable postcleaning interval in a gas at slightly above atmospheric pressure did not result in significant recontamination of the sample. This is convincing evidence that at atmospheric pressure the outgassing and diffusion rate of contaminants from surfaces is so low that a cleaned material can be used in fabrication processes without fear of recontamination from the surfaces of its environment.

Table D4 — Series-IV Glow-Discharge-Cleaning Data: Stainless Steel Samples Alternately Grounded and Ungrounded. The Date was 16 Jan. 1975.

5	0	urrent					Con	tact An	σle α.	(deg)	
Expo- sure			Gas	Rate	Pressure	R	н	•0	Io(	CHa)	Remarks
Time (min)	(A)	( $\mu$ A/cm ² )		(millitorr- liters/min)	(torr)	(cm)	Left	2° Right	Left	Right	
				Run 1 –	Sample 1	, Grou	nded			0.11	
0 0 30	0 0.300 0.300	0 26.7 28.0	Air Argon Argon	 25,850 25,850	760 0.005 0.005	 18 18	52 <10	52 <10	40 ~ <5	40 5	$ \begin{array}{c} - \\ - \\ n > 3 \Rightarrow \alpha < 10; \\ n > 4 \Rightarrow \alpha < 5 \end{array} $
				Run 2 —	Sample 2	Ungro	ounde	d			
0 30	0 0.300	0 0	Air Argon	27,350	760 0.005	 18	51 22	51 20	42 13	42 12	1 1
	<u> </u>			Run 3 -	- Sample	3, Gro	unded				
0 0 30	0 0.300 0.300	0 21.7 22.5	Air Argon Argon	25,850 25,850	760 0.005 0.005	 28 28	$\frac{47}{13}$	48 	$\frac{41}{<5}$	$\frac{41}{<5}$	$\frac{-}{n > 4} \Rightarrow \alpha < 5$
	L	L	L	Run 4	Sample 4	, Ungro	ounde	d	·		
0 30	0 0.300	0 0	Air Argon	27,350	760 0.005	 28	50 8	50 8	42 <5	42 <5	$n > 4 \Rightarrow \alpha < 5$
				Run 5	— Sample	5, Gro	undeo	1			
0 0 30	0 0.300 0.300	0 9.3 9.9	Air Argon Argon	27,350 27,350	760 0.005 0.005	 38 38	45 	<u>46</u> 11	49 <5	49 <5	$\frac{-}{n > 4} \Rightarrow \alpha < 5$
	•	· · · · · · · · · · · · · · · · · · ·	•	Run 6 —	Sample 6	, Ungro	ounde	d		·	· · · · · · · · · · · · · · · · · · ·
0 30	0 0.300	0 0	Air Argon	27,350	760 0.005	38	45 8	45 8	42 <5	42 <5	$n > 4 \Rightarrow \alpha < 5$

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Table D4 (Concluded) — Series-IV Glow-Discharge-Cleaning Data:Stainless Steel SamplesAlternately Grounded and Ungrounded.The Date was 16 Jan. 1975.

											·
Expo-	C	irrent		Gas Flow			Con	act An	gleα,	(deg)	
sure Time	Total	Sample	Gas	Rate (millitorr-	Pressure (torr)	R (cm)	Н	20	I ₂ (C	(H ₂ )	Remarks
(min)	(A)	$(\mu A/cm^2)$		liters/min)	() /	(,	Left	Right	Left	Right	
<u></u>	TTO A TO SHE			Run 7 –	· Sample 7	', Grou	nded				
0	0	0	Air	-	760	_	51	51	38	38	-
0 30	0.300 0.300	7.1 8.8	Argon Argon	50,000 50,000	0.050 0.050	18 18	21	20	-7	-9	-
	Li			Run 8 –	Sample 8	, Ungro	ounded	1			
0	0	0	Air	-	760	_	52	51	39	39	_
30	0.300	0	Argon	50,000	0.050	18	10	11	<10	<10	$n > 3 \Rightarrow \alpha < 10$
				Run 9 -	- Sample 9	, Grou	inded				
0	0	0	Air	-	760	-	46	46	50	48	-
30	0.300	6.2 6.1	Argon	50,000	0.050	28 28	15	 16	<10	<10	$n > 3 \Rightarrow \alpha < 10$
	L		·	Run 10	Sample 10	), Ungr	ounde	d			
0 30	0 0.300	0 0	Air Argon	50,000	760 0.050	28	65 10	65 11	50 9	50 9	
	<u> </u>	L	، <u>م</u> مالية الم	Run 11 -	Sample 1	1, Gro	unded		[]	ا ــــــــــــــــــــــــــــــــــــ	
0	C	0,	Air	-	760	-	65	65	58	58	-
30	0.300	T	Argon	50,000	0.050	38	15	13	<10	<10	$n > 3 \Rightarrow \alpha < 10$
			·····	Run 12 -	Sample 12	2, Ungr	ounde	d	,		
0 30	0 0.300	0 0	Air Argon	 50,000	760 0.050	38	35 11	35 11	43 <5	43 <5	$n > 4 \Rightarrow \alpha < 5$
				Run 13 –	Sample 1	3, Gro	unded				
0	0	0	Air		760	-	63	64	44	45	-
30 1080*	0.300	0	Argon Argon	23,480 23,480	0.005	18 18	65	65	58	58	Low press. overnight

*Footnote on Table D3b. †The microammeter had been borrowed and was returned.

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Table D5 – Series-V Glow-Discharge-Cleaning Data: Aluminum Oxide  $(A1_2O_3)$  Gyroscope Bearings (Avco). Sample currents were not measured because the borrowed microammeter had been returned

				Gas Flow			Cont	tact An	gle, α	(deg)	
ple	Expos- Time	Current	Gas	Rate (millitorr-	Pressure (torr)	R (cm)	Н	20	I2(0	CH ₂ )	Remarks
side	(min)	(A)		liters/min)			Left	Right	Left	Right	
				Run 1	— 30 min	at 0.0	10 torr		-		
1-1 1-1	0 30	0	Air	0 28,900	760		69 14	70 15	49 <5	48 <5	$n \ge 4 \Rightarrow \alpha < 5$
2·1 2·1	0 30	0 0.200	Air Argon	28,900 28,900	760 0.010	18	63 16	61 16	41 <5	43 <5	$n > 4 \Rightarrow \alpha < 5.$
i	L	I	<b>L</b>	Run 2	— 30 min	at 0.0	10 tor	r	L		L
1.2	0	0 200	Air	0	760		75	74	52	52	
2.2	0	0.300	Air	28,900	760	10		- 7	$\frac{10}{<10}$		$n > 3 \Rightarrow \alpha < 10$
2-2		0.400	ALBOIL	20,000 Run 3	$-60 \min$	at 0.0	005 tor	L' r	~10		
1.1	0	0	A ;		760		40		25	22	
1.1	60	0.100	Argon	27,000	0.005	18	40 14	14	<5	<5	$n > 4 \Rightarrow \alpha < 5.$
1-2	60	0.200	Air Argon	27,000	760 Ú.005	18	56 14	50 14	50   <5	50 <5	$n > 4 \Rightarrow \alpha < 5.$
			•	Run 4	— 60 min	at 0.0	005 tor	r	•	· · · · · · · · · · · · · · · · · · ·	
2-1 2-1	0	0 300	Air	0 23 600	760		45	45	38	37	-
2-2	0	0 400	Air	25,000	760	10	49 13	50	41		$n > 4 \Rightarrow \alpha < 5$
			Aigon	20,100 Run 5	-15 hou	rs at 0	.012 to				
					20.00						
1-1 1-1	900	0.100	Air Argon	?	0.012	18	<2.5	<2.5	47	46	$n \ge 5 \Rightarrow \alpha \le 2.5;$
2-1 2-1	0 900	0 0.100	Air Argon	0 ?	760 0.012	 18	50 <2.5	51 <2.5	47	46 <1	$n > 7 \rightarrow \alpha < 1$ n > 5; n > 7.

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	Euros	C	urrent		Cas Elam			Con	tact Ang	le, a (d	eg)	
Sample No.	Time	Total	Average	Gas	(mtorr-	Pressure (torr)	R (cm)	Н2	0	I ₂ (0	CH2)	Remarks
	(min)	(A)	$(\mu A/cm^2)$		1/min)			Left	Right	Left	Right	
					Run	1 — At 350	v					
Ruby	0 60	0 0.200	0 2.4	Air Argon	0 16,000	760 0.005		68	-72	30 <1	28 <1	$n > 7 \Rightarrow \alpha < 1.$
Sapphire	60 60	0.200	0 2.4	Air Argon	16,000	760 0.005	18	48 <5	48 <5	32 —	32	$n > 4 \Rightarrow \alpha < 5.$
					Run	2 – At 405	v					
Ruby 2	0 60	0	0 2.4	Air Argon	0 22.000	760		56 <10	58 <10	31	31	$n > 3 \Rightarrow \alpha < 10$
Sapphire 2	0 60	0 0.200	0 2.4	Air Argon	22,000	760 0.0033		62 4;<5	62 <5	$^{32}_{<10}$	32 <10	n > 4; n > 3.
					Run	3 — At 450	v					
Ruby 3	0 60	0 0.200	0 2.4	Air Argon	0 11,500	760 0.002		_51	51	30 <5	31 <5	$n > 4 \Rightarrow \alpha < 5.$
Sapphire 3	0 60	0 0.200	0 2.4	Air Argon	0 11,500	760 0.002	18	53 <5	55 <5	40 <5	37 <5	$n > 4 \Rightarrow \alpha < 5.$

Table D6a – Series-VIA Glow-Discharge-Cleaning Data: Synthetic Rubies and Sapphires  $(A1_20_3)$ 

Table D6b — Series-VIB Glow-Discharge-Cleaning Data:  $A1_20_3$  Avco Bearings

	France	C	urrent		Cos Flow			Con	tact Ang	le, α (d	eg)	
Sample No.	Time	Total	Average	Gas	(mtorr-	Pressure (torr)	R (cm)	H ₂	0	I ₂ (C	H2)	Remarks
		(A)	(µA/cm ² )					Left	Right	Left	Right	
					Run 4	4 – At 405	v					
1-1 1-1 2-1 2-1	0 60 0 60	0 0.200 0 0.200	0 2.4 0 2.4	Air Argon Air Argon	0 20,500 0 20,500	760 0.0033 760 0.0033	 18  18	45 <5 40 6;<10	48 <5 41 7; 0</td <td>28 5;&lt;5 34 &lt;5</td> <td>27 3;&lt;5 30 &lt;5</td> <td>$n &gt; 4 \Rightarrow \alpha &lt; 5.$ n &gt; 3; n &gt; 4.</td>	28 5;<5 34 <5	27 3;<5 30 <5	$n > 4 \Rightarrow \alpha < 5.$ n > 3; n > 4.
					Run !	5 – At 450	v				·	
1-2 1-2 1-2 2-2 2-2 2-2 2-2	0 60 2 0 60 3	0 0.200 0 0.200 0	0 2.4 0 2.4 0 2.4 0	Air Argon Rm air Air Argon Rm air	0 11,400 0 11,400 0	760 0.002 760 0.002		70 <5 - 72 <2.5 5	70 < 5 - 68 < 2.5 4	- 25 - <5 -	-<5 25 -<5 -	$n > 4 \Rightarrow \alpha < 5.$ $n > 5; n > 4.$

Sample		Funas	Cı	urrent		Cas Flow			Con	tact An	gle,α(	(deg)	
Tune	No. and	Time*	Total	Average	Gas	(mtorr-	Pressure (torr)	R (cm)	H	2 ⁰	I ₂ (C	CH2)	Remarks
rype	Side	()	(A)	$(\mu A/cm^2)$		17111117			Left	Right	Left	Right	l
A1,03 bearing	1-1	0	0	0	Air	0	760	-	77	72	37	37	
20		120	0.200	2.4	Argon	22,800	0.002	18	15	13	<b>\$2.5</b>	<b>\$2.5</b>	$n \geq 5 \Rightarrow \alpha \leq 2.5$
		240	0.200	2.4	Argon	22,800	0.002		$ \geq_{5}^{2}$	$\geq_{5}^{2}$	2.5	2.5	n < 4, n < 5.
	2.1	0	0.200	ő.4	Air	22,000	760	10	70	72	41	42	
		120	0.200	2.4	Argon	22,800	0.002	18	15	15	<2.5	<2.5	$n > 5 \Rightarrow \alpha < 2.5$
		240	0.200	2.4	Argon	22,800	0.002	18	<5	<5	<2.5	<2.5	$n \ge 4; n \ge 5.$
<b>n</b> .		340	0.200	2.4	Argon	22,800	0.002	18	<2.5	<2.5	<2.5	<2.5	n > 5 ⇒ α < 2.5
Ruby	3		0 000	0	Air		760	10	62	63	33	33	
		240	0.200	2.4	Argon	22,800	0.002	18		-	<25	<25	$n > 5 \Rightarrow \alpha < 2.5$
	}	340	0.200	2.4	Argon	22,800	0.002	18	<5	<5			$n > 4 \Rightarrow \alpha < 5$ .
Sapphire	4	Ŏ	0	Ō	Air	0	760	- 1	68	73	43	43	-
••	l	120	0.200	2.4	Argon	22,800	0.002	18	14	<5	<5	<5	$n > 4 \Rightarrow \alpha < 5.$
		240	0.200	2.4	Argon	22,800	0.002	18	<2.5	<2.5			$n \ge 5 \Rightarrow \alpha \le 2.5$
Challed an about	۲ - I	340	0.200	2.4	Argon	22,800	0.002	18		-	<2.5	<2.5	$n > 5 \Rightarrow \alpha < 2.5$
Stainless steel	b	120	0 200	24	Argon	22 800	100	1.9	12	18	43 <25	43 <25	$n > 5 \Rightarrow \alpha < 95$
		240	0.200	2.4	Argon	22,800	0.002	18	10	10	21.2	<15	$n > 6 \Rightarrow \alpha < 1.5$
		340	0.200	2.4	Argon	22,800	0.002	18	<š	<5 <	1<1.5	1<1.5	n>4; n>6.
Stainless steel	6	0	0	0	Air	0	760		55	59	42	43	· · · · ·
		120	0.200	2.4	Argon	22,800	0.002	18	20	18	<2.5	<2.5	$n \ge 5 \Rightarrow \alpha \le 2.5$
		240	0.200	2.4	Argon	22,800	0.002	18	<u>9</u>	7	$  \leq 1.5$	$  \leq 1.5$	$n \ge 6 \Rightarrow \alpha \le 1.5$
		340	0.200	j 2.4	Argon	22,800	0.002	18	<5	<5	<1.5	1.5	n > 4; n > 6.

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Table 7 — Series-VII (Run 1) Glow-Discharge Cleaning Data:Samples Precontaminated with Dow Corning<br/>Pump Oil No. 704 (Silicone Oil) Overnight and Then Washed, Rinsed, and Air D-ied.

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*The vacuum system was backfilled with nitrogen at the end of each time interval for contact-angle measurements on all samples before restarting. Therefore the time is accumulative, and the samples were recontaminated with I₂(CH₂) and H₂O by the contact-angle measurements.

#### **Reprint of NRL Memorandum Report 3201**

A Method to Estimate the Contact Angle of a Drop Spread Upon a Flat Surface when it is Otherwise too Flat to Measure

#### INTRODUCTION

In the course of measuring the amount of contamination present on a clean surface after cleaning, a relationship between the contact angle of a small drop on the surface and the contamination is used according to established criteria (see Refs. 1 - 4).

The contact angle is measured with the use of a small microscope and its appropriate lighting system called a Goniometer. The angle measurements become increasingly vague and difficult as the drop spreads and the contact angle becomes less than  $5^{\circ}$ . This has not caused a great deal of concern, since in the past most contact angles were greater than  $15^{\circ}$ . However, during an experiment using an improved method of plasma cleaning of surfaces it was found that the drop spread so thin on the surface that its profile could not always be observed. Such is often the case when the contact angle is  $5^{\circ}$  or less. This memorandum discusses a means of estimating the contact angle from  $10^{\circ}$  to  $0.5^{\circ}$  with a certainty which is dependent on the accuracy of the knowledge of the volume of the original drop, and its diameter when spread out over the surface of the clean specimen.

The experiment data to test the following theory, was accumulated by measuring drops on optically flat specimens made of stainless steel, sapphire, ruby and an aluminum oxide bearing. The angles were measured from photographs so that the height to diameter ratio and contact angle measurements could be fixed in time, since the drop size changed rather rapidly as a function of time, (evaporation rate, and recontamination rate). The data is plotted in Fig. 3 and tabulated in Table 1.

Note: Manuscript submitted December 24, 1975.

For the purposes of this analysis a small drop is defined as a drop size where the maximum hydrostatic force within a drop resting on a clean surface is less than the force due to surface tension acting the drop. Experimental evidence included in the subsequent data confirms the definition within the limits of the observations.

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Fig. 1 - The geometrical relationship of the contact angle of a small drop on a level. flat surface, to a spherical drop of equal volume 2

#### Section 1

### The spreading ratio

If it is assumed that a small drop spreading evenly on a flat surface forms a spherical segment, then the relationship of the diameter of the initial drop before contact can be related to the diameter of the spherical segment by the fact they have equal volumes. Thus by simple geometry

Volume of Sphere = 
$$\frac{3}{4} \pi R^3$$
. (1)

Volume of spherical segment 
$$\equiv \frac{1}{3} \pi h^2 (3 R_2 + h)$$
, (2)

where h = height of segment (Fig. 1)  $R_2$  = radius of curvature of the segment  $R_1$  = radius of the initial drop, and define  $nR_1$  =  $r_2$  = radius of the segment base. Then combining Eqs. (1) and (2),  $r_2$  is related to  $R_2$  by 3.

$$\frac{4}{n^3} = h^2(3 R_2 - h). \quad \underline{"n" \text{ is the spreading ratio}}. \tag{3}$$

From the geometry it can be seen that

$$\sin \alpha/2 \equiv \frac{1}{2} \sqrt{h^2 + r_2^2/R}_2 \equiv \sqrt{\frac{h^2 + r_2^2}{2R}_2} \equiv \sin \alpha_i$$
(3a)

because of similar triangles, and because  $\alpha$  = the contact angle = 2  $\alpha_i$ ,

then

$$\operatorname{Tan} \alpha_{i} = h/r_{2} = \frac{r_{2}}{2 R_{2} - h}$$
 (3b)

$$\alpha = 2 \tan^{-1} h/r_2 \text{ and } (3c)$$

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Thus

$$r_2^2 = h(2 R_2 - h)$$
 . (4)

Combine Eq's (3) and (4) to eliminate R, then simplify to

$$\frac{\mathbf{h} \mathbf{r}^{3}}{\mathbf{n}^{3}} = \frac{\mathbf{h}}{2} (3 \mathbf{r}_{2}^{2} + \mathbf{h}^{2}),$$

thus

$$\frac{1}{n^3} = \frac{1}{8} \left[ \frac{h}{r_2} \left( 3 + \frac{h^2}{r_2^2} \right) \right] \quad . \tag{5}$$

Solve for n,

$$n = 2 \left[ \frac{h}{r_2} \left( 3 + \frac{h^2}{r_2^2} \right) \right]^{-\frac{1}{3}} = 2 \cot \frac{\alpha}{2} \left[ 1 + \cot^2 \frac{\alpha}{2} \right]^{-\frac{1}{3}} .$$
 (6)

Equation (5) is used to calculate the curve (nomograph) of contact angle vs n (Fig. 2).

If a small drop spreading evenly on a flat surface forms a spherical segment of a larger sphere, then  $\alpha/2 = \tan^{-1} h/r_2$ . Therefore the measurement of the  $\alpha_i$ s,  $h_i$ 's and  $r_{2i}$ 's for a series of different drops should, within the precision of the measurements, correspond to the geometric relationship.

A series of photographs were taken of drops on surfaces with different degrees of contamination.

The results of the measurements are points  $\alpha$  vs h/r from Eq. (3c).

The fact that most of the points are below the line may indicate a systematic error in the measurements, or it may indicate that the shape of the assumed spherical segment becomes a little flat as the radius of curvature increases. In either case the observed angles are slightly less than they would be if calculated from the observed  $h/r_{o}$ .



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Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

ers	α,	deg	2.59	1	1	1	1	1	1	8.75	10.75	3.82	18.53	8.95	8.08	5.42	8.75	16.18	11.05	15.43	8.58	8.26	18.80
ted Paramet	Ratio	h/r ²	0.0226	1	•	•	1	1	1	.07647	.09411	.05333	. 16316	.07826	.07059	. ot 757	. o7647	.142105	.09697	. 13548	.075	.07222	. 16552
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	Dia.	-p ⁰¹	35.4	1	ı	1	1	1		34	34	36	к) 8	4:6	34	38	34	38	33	31	32	36	59
ameters	lleight	<u>я</u>	4.0	1	1	1	1	ı	1	1.3	1.6	0.6	3.1	1.8	1.2	0.9	1.3	2.7	1.6	2.1	1.2	1.3	4.5
sured Par	le(α)	Ríght	$\alpha < 5^{\circ}$		ω	5			1	7	दा	4	1	8	8	ı	8	1	10	16	8	7	17
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Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

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Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

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	Dia.	'n				17	24.3	24.8	20.9	1	32.0	26.7	26.5	26.7	32.0				21.3		25.0	_	22.2	
ameters	Height	ų				9.6	8.1	8.1	8.1	1	3.2	3.1	3.1	3.7	3.9	Balance	:	=	7.6	Focus	6.8	Focus	4.7	
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# Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

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Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

eters	ğ	deg		2.40			9.67		9.55		11.42		6.70	9.53	12.35	15.13	8.29	24.28	32.26	10.44	51.56	
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rameters	Height	<b>.</b> .		0.7			1.4		1.1		1.7		0.0	1.0	1.3	1.6	1.0	2.7	3.5	0.9	5.7	
isured Pai	e(α)	Right		1	2 - 3		1	7 - 8	ω			6	ω	10	11	15	7	56	35	12	50	
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Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

ters	ے۔ deg	7.82		4.58		4.45		14.67	14.34	13.63		15.84			9.91			6.54
red Parame	Racio h/r 2	.05838		.04:000		.038899		. 12875	.12579	.11950		51951.			.17544			.05914
Lo`cula	r. r.	11.7		12.5		18.0		11.65	15.9	15.9		17.25			12.1			17.5
	Dia. d	23.4		25.0		36		23.3	31.8	31.8		34.5			34.2			35.0
ameters	licight h	0.8		0.5		0.7		1.5	2.0	1.9		5. ⁴			3.0			1.0
isured Par	c(a) Rıght	ı		α < 5°			3 - 4	<u>업</u>	14	15			15 - 16			15 - 17		1
Mea	Left	α < 5 ⁰	α < 5°		ñ			CI CI	71	17	i5 - 17			14 - 16			5 - 7	1
re Time	To rilm Sec	1/30	=	=	=	=	=	=	2	=	Ξ	=	=	:		2	===	2
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le	Number	2	ñ	ĸ	-7	t	 *	5	9	7	ω	ω	89	6	6	6	10	10
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rap! ic	Frame	1	0	m	4	s	<u>ب</u>		æ	6	10	11	ង	ີ ເລ	 71	15	15	11
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Contact Angle vs Spreading Ratio Measurements from Photographs of Drop Profiles on Surfaces

cors	σ	deg ^o		37.14	37.57	33.32	28.19	30.05	26.57	36.72	31.17	25.53	28.67	28.67	28.67	32.02	34.78	22.77	32.5	34.48	11.71
ted Parame	Ratio	h/r 2		.33600	-34014	12662.	.25105	.268;0	.23611	.33184	.27888	.22656	.25559	.25559	.25559	.26696	.31317	. 50139 .	-29162	.31034	.10255
Cilcula	suint	561		12.5	14.7	6.35	11.95	11.55	14.4	11.15	12.55	12.8	15.65	15.65	15.65	11.5	14.05	14 .4	11. 4	14.5	19.5
	Dic.	ئ م		25.0	29.4	12.7	23.9	23.1	28.8	22.3	25.1	25.5	31.3	31.3	31.3	23.0	28.1	28.8	28.8	29.0	39.0
ameters	licight	.r.	ł	4.2	5.0	1.9	3.0	3.1	3.4	3.7	3.5	2.9	0°.‡	0°†	4.0	3.3	7-1	2.9	4.2	4.5	2.0
sured Par	e(ơ)	Right	l, - 5	34	37	34:	32	32	2ó	34	30	50	52	2tł	52	32	31	50	54	35	ន
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For the purpose of estimating contact angles, the curve in Fig. 3 was assumed to be essentially correct for contact angles down to 1.0 degree where 6 < n < 7 and the corresponding value of  $h/r_2 = 8.727 \times 10^{-3}$ .

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All estimations of "n" were deliberately conservative. For "example" when n appeared to be at least 9 but possibly 8, n > 7 was the ratio chosen on the side of caution, and implies that  $\alpha < 1^{\circ}$ . Hence the recorded notation;  $n > 7 \rightarrow \alpha 1^{\circ}$ . Allowance for over estimating the spreading ratio is about 25%. Therefore it is assumed that all the contact angle estimates are at the larger limit, but the actual contact angles are often significantly smaller. An accurate measurement of the spreading ratio may be available in the future if more sophisticated optical instrumentations becomes available.

D was determined by using a fine hypodermic needle as a drop source and counting the number of apparently uniform size drops on an optically flat surface. A 1,000  $\mu$  liter gas tight #1001 syringe was used with a #25 size hypodermic needle the results are shown in Table 2. A slightly smaller drop was obtained when using the same size needle coated with a fluoro-carbon compound (5) to reduce its surface energy but the difference in the volume was reduced only about 1/3 and the resulting reduction in diameter was only about 15%. For the purposes of this experiment, the reduction of the drop diameter was too small to be significant.

#### Section 2

#### Drop size criteria

This section represents an attempt to establish a reasonable criteria for choosing a drop size which yields a spherical segment, as suggested by the definition accompanying Fig. 1. A small drop is defined as a drop size where the maximum hydrostatic force due to gravity is less than the force due to surface tension acting on the drop.

The pressure due to gravity is

$$P_g = (h - h_i)g\rho , \qquad (6)$$

where

P_g = hydrostatic pressure due to gravity
h = height of the drop
h_i = height of pressure point above the base
ρ = density of the liquid in the drop
g = acceleration of gravity

From Eq. (3a)  $\alpha/2 = \alpha_i$ , thus  $\tan \alpha/2 = h/r_2$  and  $h = r_2 \tan \alpha/2$ . Therefore when  $h_i = 0$ 

$$P_{g} = (r_{2} \tan \alpha/2) \text{ gp is a maximum pressure.}$$
(7)

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$$P_{T} = \frac{2\sigma}{R_{2}} = \text{pressure within the spherical segment}$$
(8)  
$$P_{T} = \frac{2\sigma}{R_{2}} = \text{due to surface tension. From Eq. (4)}$$
$$P_{2} = h(2R_{2} - h), \text{ therefore}$$

$$R_{2} = \frac{1}{2 h} (r_{2}^{2} + h^{2}) \equiv \frac{r_{2}}{2 \sin \alpha/2 \cos \alpha/2}$$

Thus

$$P_{\rm T} = \frac{\frac{\mu_{\rm o} (\sin \alpha/2 \cos \alpha/2)}{r_{\rm cos} \alpha/2}}{r_{\rm cos} \alpha/2} \qquad (9)$$

Therefore, since the arbitrary criteria for a small drop requires that  $P_g < P_T$  then  $P_T/P_g > 1$ . However,

$$P_{T}/P_{g} = \frac{4 \sigma (\sin \alpha/2 \cos \alpha/2)}{r_{2}(r_{2} \tan \alpha/2)g\rho} > 1$$

which is identical to

$$\frac{\frac{4 \sigma \cos^2 \alpha/2}{r_2^2 g\rho} > 1, \text{ or } \frac{4 \sigma \cos^2 \alpha/2}{(nR_1)^2 g\rho} > 1,$$

where  $R_{1}$  is the radius of the small drop and "n" is the spreading ratio.

Assume a range of values  $0.3^{\circ} < \alpha < 20^{\circ}$ according to Eq. (4) 10 > n > 2.5and in the same order,  $0.999996 \ge \cos \alpha/2 \ge 0.9848$ ,

then

$$n < \sqrt{\frac{4 \sigma \cos^2 \alpha/2}{R_{\perp}^2 g\rho}} \equiv \frac{2 \cos \alpha/2}{R_{\perp}} \sqrt{\sigma/g\rho}$$

Consider a drop of water,  $\sigma \approx 72$  dynes/cm,  $\rho \approx 1$  gm/cm³, g = 980 cm/sec².

$$n < \frac{0.5338 \text{ cms}}{R_1 \text{ cms}}$$

the average drop diameter of water in Table 2 was 0.2616 cms

$$R_1 = \frac{.2616}{2} = .1308 \text{ cms},$$

therefore n < 4.08. This implies that as long as the spreading ratio is less than 4 the criteria for drop size is met. The fact that the shape approximates a spherical segment, does not mean that I pretend to imply that this criteria proves that the drop will have a spherical shape. It is only a means to keep the drop within a reproducible size. Then, within this size limitation the curve illustrated in Fig. 3 of h/r to  $\alpha$ will produce an experimental verification of the method of determining the contact angle within the observed range.

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Determination of Drop Diaméters "A" Using a Clean  $\pounds 25$  Hypodermic Needle with a Squared off Tip

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tge Average Kax. p Drop "n" me Diam. mm	158 151 134 150 2.616 4.08	75 22 194 775 2.003	284 1.239 3.11 coated with [Poly-C ₁₇ F ₁₅ CH 00CC (CH ₃ ) = CH ₂ ]	-79 2.235 4.78	strength of the drop should be proportional to its bended from the needles point. At $20^{\circ}$ C we have $S_{2}^{\circ} = K_{2}^{\circ}$	۲ = 78 dynes/cm, p = 1, p = 3.3.	nes/cm which compares well with the accepted value of
Number Averag of Drop Drops Volume ma ³	101 104 9.545 171.9 100 101 100 101 101	234 4.273 242 4.132 237 4.219 237 4.207	262 I.908 dle simiiar "A" but o	171 5.8475	tency, the tensile s e largest drop susper ilarly wT of $I_2(CH_2)$	and $\gamma_{2} = \frac{R^{2} \rho}{R^{2} \rho} \frac{\gamma}{1}$	9/2. γ ₂ ≃ 52.4 dyne
Total Volume mm ³	1000 ± 5 1000 ± 5 1000 ± 5	1000 ± 5 1000 ± 5 1000 ± 5	500±5 using a clean <del>*</del> 25 neeu	1000 ± 5	ck for internal consis thus to the mass of th $(R^3)(\rho_1) = K_1\gamma_1$ . Sim	$\therefore \frac{\left(\frac{X}{2} \times 2\right)}{\frac{X}{2}} = \frac{\omega T (\frac{1}{2} \circ 2)}{\omega T (1_{2} \circ CH_{2})}$	2.615/2 and R = 1.53
Type of Liquid	1.) н ₂ 0 2.) н ₂ 0 3.) н ₂ 0	4.) 2 - Propanol 5.) 2 - Propanol 6.) 2 - Propanol	7.) I ₂ (CH ₂ )	в.) н ₂ 0	To use a chesurface tension, wr of $H_2^0 = \frac{4}{3} \pi$		Substituting R =

1.12

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